



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7449**
Kazuhiro OTSU et al. : Docket No. 2002_0208A
Serial No. 10/067,370 : Group Art Unit 2818
Filed February 7, 2002 : Examiner Thao P. Le

SEPARATING MACHINE FOR THINNED
SEMICONDUCTOR SUBSTRATE AND
SEPARATION METHOD

AMENDMENT

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of June 6, 2003, the period for response having
been extended for two (2) months by the attached petition, please amend the present
application as follows:

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